To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a

Signature

true copy of the original document. Charges to deposit account are authorized, as indicated herein.

Statement and Signature

Jeffrey A. Wyand; Reg. No. 29,458

Name of Person Signing

PATENT

REEL: 011317 FRAME: 0146

ASSIGNMENT

	1.00101.11.12.11	
In consideration of the premises is hereby acknowledged, the undersigned		ation in hand paid, the receipt and sufficiency of which
(1) Takumi NAKAHATA	(4) Naruhisa MIURA	(7)
(2) Shigemitsu MARUNO	(5) Toshiyuki OISHI	
(3) Taisuke FURUKAWA		(9)
who have made a certain new and useful		ansfer unto
Mitsubishi Denki Kabus	hiki Kaisha of	
2-3, Marunouchi 2-chom	e, Chiyoda-ku, TOKYO	100-8310 JAPAN
its successors and assigns (hereinafter de as defined in 35 U.S.C. 100 in the inven		tht, title and interest for the United States of America
SEMICONDUCTOR DEVICE	AND MANUFACTURING MET	HOD THEREOF
(a) for which an application for United Serial No; o	States Letters Patent was filed on	, and identified by United States
(b) for which an application for United		
United States Letters Patent which may continuations, or continuations-in-part th Industrial Property to the said ASSIGN undersigned agree that the attorneys of the said agree that the said agree that the attorneys of the said agree that the said agree	the granted therefor and any and an arrect and the right to all benefits un NEE, for its interest as ASSIGNEE, record in said application shall hereafted.	development assistance in making application for
and obtaining original, divisional, reissu	ves, and without further remuneration.	ender all necessary assistance in making application for Jnited States, upon request of the said ASSIGNEE, its in and to any improvements, and applications for patent y papers by the said ASSIGNEE, its successors, assigns and title in and to the invention hereby transferred.
SIGNED on the dates indicated aside of INVENTORS	ur signatures:	DATE SIGNED
1) Jakumi hakahat	_	November 2, 2000
Name: Takumi NAKAHATA		November 2, 2000
2) Shigemitsu Maru Name: Shigemitsu MARUN	<u>n 0</u>	November 2, 2000
3) Name: Taisuke Funkan Name: Taisuke FURUKAWA 4) Naruhisa Miur	Va.	November 2, 2000
Name: Naruhisa MIURA		November 2, 2000
5) Joshyuki Oral Name: Toshiyuki OISHI		November 2, 2000
6) <u>(lasume Take da</u> Name: Yasunori TOKUDA	7	
7) Name:		
8) Name:		
9) Name:		PATENT

RECORDED: 11/21/2000

PATENT REEL: 011317 FRAME: 0147